



Form PTO-1449 (Modified)		Atty Docket No. 15675.P322	Serial No. 09/600,546
<i>List of Patents & Publications Statement</i>		Applicant(s): C. Chappert	
(Use several sheets if necessary)		Filing Date: 7/12/00	Group No. 1756

U.S. PATENT DOCUMENTS

Exam. Initials		Document Number	Date	Name	Class	Sub-class	Filing Date (if appropriate)
	AA						
	AB						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

Exam. Initials		Document Number	Date	Country	Class	Sub-class	Translation Yes	No
<i>AC</i>	AL	JP0129699	<i>11/1989</i>	Japan	—	—	X	
	AQ							

OTHER ART (Including Title, Author, Date, Pertinent Pages, etc.)

Exam. Initials		Document Identification
<i>AC</i>	AR	Xiao J Q. et al.: "Effects of ar-Ion implantation and annealing on structural and magnetic properties of CO/PD multilayers" Journal of applied Physics, vol. 76, no. 10, part 02 11/15/94, pages 6081-6083
<i>AC</i>	AS	Amaral L. et al.: "Very Thin Fe/Ni modulation multilayer films under ion bombardment" Journal of Applied Physical vol. 81, no. 8, part 02B, April 15, 1997, pages 4773-4775
<i>AC</i>	AT	Gladyszewski G. et al.: "Modification of Structure, Electric and Magnetic Properties of Epitaxially Grown Ag(001)/FE(001) Superlattices" Journal of Magnetism and Magnetic Materials, vol. 156, no. 1/03, April 1, 1996, page 381-382
<i>AC</i>	AU	Choe G. et al.: "Effect of Ion Beam Mixing on Microstructure and Magnetic Properties of GD-Co Multilayer Films" Journal of Applied Physics, vol. 79, no. 8, part 02B, April 16, 1996
<i>AC</i>	AV	Schelp L. F. et al.: "Structural and Magnetic Behavior of AR+-Implanted Co/PD Multilayers: Interfacial Mixing" Journal of Applied Physics vol. 75, no. 10, part 01, May 15, 1994

Examiner: *MJL* Date Considered: *11/14/01*

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